



## U.S. Patent Application Serial No. 10/084,925

## **IN THE SPECIFICATION:**

## Please amend the paragraph beginning at page 11, line 15 as follows:



FIG. 5A to FIG. 5F show an example of a method for fabricating the semiconductor device shown in FIG. 1 to FIG. 3 of the present invention.

## Please amend the last paragraph on page 3 as follows:

 $FIG: 4 is a cross-sectional\ view\ of\ a\ semiconductor\ device\ \frac{fabricated\ by\ a\ fabricating\ method\ in}{}$ 



FIG. 5A to FIG. 5F of related art;